

TABLE 3.3-14

RADIOACTIVE GASEOUS EFFLUENT MONITORING INSTRUMENTATION

<u>INSTRUMENT</u>	<u>MINIMUM CHANNELS OPERABLE</u>	<u>APPLICABILITY</u>	<u>ACTION</u>
1. PROCESS VENT SYSTEM			
a. Noble Gas Activity Monitor - Providing Alarm and Automatic Termination of Release	1	*	31,33
b. Iodine Sampler	1	*	31,34
c. Particulate Sampler	1	*	31,34
d. Process Vent Flow Rate Measuring Device	1	*	30
e. Sampler Flow Rate Measuring Device	1	*	30
2. WASTE GAS HOLDUP SYSTEM EXPLOSIVE GAS MONITORING SYSTEM (Shared with Unit 2)			
a. Hydrogen Monitor	1	**	32
b. Oxygen Monitor	1	**	32

TABLE 3.3-14 (Continued)

RADIOACTIVE GASEOUS EFFLUENT MONITORING INSTRUMENTATION

<u>INSTRUMENT</u>		<u>MINIMUM CHANNELS OPERABLE</u>	<u>APPLICABILITY</u>	<u>ACTION</u>
3.	CONDENSER AIR EJECTOR SYSTEM			
a.	Gross Activity Monitor	1	*	31A
b.	Flow Rate Monitor	1	*	30
4.	VENTILATION VENT SYSTEM (Shared with Unit 2)			
a.	Noble Gas Activity Monitor	1*	*	31
b.	Iodine Sampler	1*	*	31
c.	Particulate Sampler	1*	*	31
d.	Flow Rate Monitor	1*	*	30
e.	Sampler Flow Rate Monitor	1*	*	30

*One per vent stack.

TABLE 3.3-13

RADIOACTIVE GASEOUS EFFLUENT MONITORING INSTRUMENTATION

<u>INSTRUMENT</u>	<u>MINIMUM CHANNELS OPERABLE</u>	<u>APPLICABILITY</u>	<u>ACTION</u>
1. PROCESS VENT SYSTEM			
a. Noble Gas Activity Monitor - Providing Alarm and Automatic Termination of Release	1	*	31,33
b. Iodine Sampler	1	*	31,34
c. Particulate Sampler	1	*	31,34
d. Process Vent Flow Rate Measuring Device	1	*	30
e. Sampler Flow Rate Measuring Device	1	*	30
2. WASTE GAS HOLDUP SYSTEM EXPLOSIVE GAS MONITORING SYSTEM (Shared with Unit 1)			
a. Hydrogen Monitor	1	**	32
b. Oxygen Monitor	1	**	32

TABLE 3.3-13 (Continued)

RADIOACTIVE GASEOUS EFFLUENT MONITORING INSTRUMENTATION

<u>INSTRUMENT</u>	<u>MINIMUM CHANNELS OPERABLE</u>	<u>APPLICABILITY</u>	<u>ACTION</u>
3. CONDENSER AIR EJECTOR SYSTEM			
a. Gross Activity Monitor	1	*	31A
b. Flow Rate Monitor	1	*	30
4. VENTILATION VENT SYSTEM (Shared with Unit 1)			
a. Noble Gas Activity Monitor	1*	*	31
b. Iodine Sampler	1*	*	31
c. Particulate Sampler	1*	*	31
d. Flow Rate Monitor	1*	*	30
e. Sampler Flow Rate Monitor	1*	*	30

*One per vent stack.

Transmitting Amendments (also Corrections to Amendments)

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AMENDMENT NOS. 109 & 95 TO FACILITY OPERATING LICENSE NOS. &

Docket File

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